

F-7336



10/070516

PCT
JCO5 Rec'd 27 MAR 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hideo YOSHIDA et al.
Serial No. : Not yet known (U.S. National Stage of PCT/JP01/06525
filed July 30, 2001)
Filed : Concurrently herewith
For : METHOD OF ELECTROCHEMICAL TREATMENT SUCH
AS ELECTROPLATING, ETC. AND ELECTROCHEMICAL
REACTION APPARATUS THEREOF
Examiner : Not yet known
Group Art Unit : Not yet known

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, DC 20231 on March 19, 2002.

C. Bruce Hamburg
(Name)


(Signature)

Assistant Commissioner for Patents
Washington, D.C. 20231

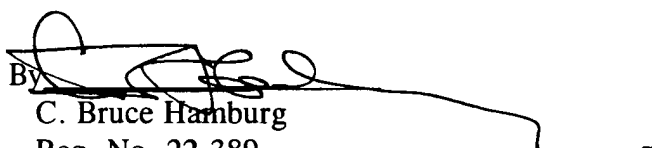
CLAIM OF SMALL-ENTITY STATUS

Sir:

Small entity status is hereby claimed.

Respectfully submitted,

JORDAN AND HAMBURG LLP

By 
C. Bruce Hamburg
Reg. No. 22,389
Attorney for Applicants

122 East 42nd Street
New York, New York 10168
(212) 986-2340

RECEIVED
JUN 27 2002
TC 1700

COPY OF PAPERS
ORIGINALLY FILED